

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant:	TSUTOMU YAMADA	1, 1,
Serial No.) Group Art Unit: 2879 6 2004) Examiner: K. Ramsey 700
Filed:	December 26, 2000) Examiner. K. Ramsey 00
For:	DEPOSITION MASK AND MANUFACTURING METHOD THEREOF, AND ELECTROLUMINESCENCE DISPLAY AND MANUFACTURING METHOD THEREOF))))

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 19, 2003, Applicant requests reconsideration in view of the following remarks for entry in the above-identified application.

I hereby certify that this correspondence is being Mailed via First Class Mail to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Agatha Skierkowski

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date